

Notice of References Cited

Application/Control No.

10/572,855

Applicant(s)/Patent Under
Reexamination
SHIMADA ET AL.

Examiner

JOHN K. KIM

Art Unit

2834

Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0201685	10-2003	Shimada et al.	310/156.53
*	B	US-2002/0114824	08-2002	Fukui et al.	424/432
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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